Shinno-Yoshioka Group

Production engineering based on innovative precision mechanical devices

Innovative Mechano-Device Research Core Laboratory for Future Interdisciplinary Research of Science and Technology

http://www.upm.pi.titech.ac.jp

Research field of our research group is future production system which is higher higher precision, productivity, and flexible. In order to achieve that goal, we have developed an ultraprecision machining measuring and systems based on innovative design concept, components functional such as positioning system, monitoring systems

Sensor-integrated cutting tool

- Micro thermometry sensor on rake face of cutting tool
- Inprocess monitoring of thermal behavior near cutting point
- Adaptive control of ultraprecision cutting using monitoring information



Nano measuring system by integrating innovative mechanical devices

- Ultraprecision motion based on non-contact structure
- Abbe-error minimized layout of mechanical components
- Wide measuring range from nanometer to millimeter





- Production engineering
- Ultraprecision machinery system
- Precision mechanical device

Ultraprecision positioning system

- Sub-nanometer positioning table system by minimizing structural error factors
- Tiling positioning platform driven by a hybrid actuator combined electromagnetic and pneumatic actuators



Nano machining system by integrating innovative mechanical devices

- Ultraprecision motion based on non-contact structure
- Stable structure with rigid and low thermal expansion material
- Inprocess monitoring function and nano machining based on feedback of the monitoring result



